

Serial No. 09/943,383



Docket No.: 005920 USA/MTCG/PCTRL/JW

PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,383

Filed: August 31, 2001

:
:
:
:
:
:

Group Art Unit: 2862

Examiner: William David Coleman

For: IN SITU SENSOR BASED CONTROL OF SEMICONDUCTOR PROCESSING
PROCEDURE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. IT is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Applicants' representative certifies that the enclosed document was cited in a communication from the World Intellectual Property Office in a counterpart PCT application not more than three months before the filing date of this Information Disclosure Statement. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References

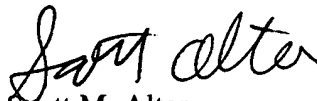
Serial No. 10/685,210

the filing date of this Information Disclosure Statement.

No fee is believed to be required; however, the Commissioner is authorized to charge any deficiency in any fees pursuant to 37 CFR § 1.17 associated with this communication and to credit any excess payment to Deposit Account No. 08-0219.

Respectfully submitted,

WILMER CUTLER PICKERING HALE AND DORR LLP



Scott M. Alter

Registration No. 32,879

1600 Tysons Boulevard
Suite 1000

McLean, Virginia 22102

phone: (703) 251-9700

fax: (703) 251-9797

Date: 5/20/05

